

A DOCPHOENIX

APPL PARTS

THU C
IMIS
Internal Mise Paper
ACCOUNT LET
Misc. Incoming Letter
371P
PCT Papers in a 371Application
Α
Amendment Including Elections
ABST
Abstract
ADS
Application Data Sheet
AF/D Affidavit or Exhibit Received
APPENDIX
Appendix
ARTIFACT
Artifact
BIB
Bib Data Sheet
CLM
Claim
COMPUTER
Computer Program Listing
CRFL
All CRF Papers for Backfile
DIST
Terminal Disclaimer Filed
DRW
Drawings
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Foreign Reference
Foreign Priority Papers
IDS
IDS Including 1449

NPL
Non-Patent Literature
OATH
Oath or Declaration
PET.
Petition
RETMAIL
Mail Returned by USPS
SEQLIST
Sequence Listing
SPEC
Specification
SPEC NO
Specification Not in English
TRNA
Transmittal New Application
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Count Non-Final	
	CTRS
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Examiner Intervi	ew
	M903
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	M905
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1	NFDR
Formal Drawing	Required
1	AOV
Notice of Allowar	nce
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Petition Decision	

OUTGOING

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APDEC
Board of Appeals Decision
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CTAV
Count Advisory Action
CTEQ
Count Ex parte Quayle
CTFR
Count Final Rejection

Appeal Brief	P.B
C.A	ND
Notice of Appeal	AP
Change in Power of	***
Applicant Remarks i	
Extension of Time f	·

INCOMING

Internal **SRNT** WCLM **Examiner Search Notes** Claim Worksheet CLMPTO WFEE PTO Prepared Complete Claim Set Fee Worksheet

FWCLM	
File Wrapper Claim	_
IIFW	
File Wrapper Issue Informati	on
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File Wrapper Search Info	
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File Wrapper

4/25/03

Substitute for form 1449A/PTO (modified)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Page 1 of 2

Application Number	10/009308
Filing Date	November 13, 2001
First Named Inventor	Yamanaka, Keizo
Art Unit	1771
Examiner Name	
Attorney Case Number	54888US006

Te Tab	1		U.S. Patent	Documents		
Exam. Init.*	Cite No.	Document Number Doc. Number-(Kind Code if Known)	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, When Relevant Passages or Relevan Figures Appear	
	A1	US- 2,642,416	06-16-1953	Ahlbrecht et al.		
	A2	US- 3,318,852	05-09-1967	Dixon	2	
	A3	US- 3,536,749	10-27-1970	Groves	YAL CA	
	A4	US- 3,574,791	04-13-1971	Sherman et al.	THE CRITICAL TO THE CRITICAL T	
<u> </u>	A5	US- 3,944,527	03-16-1976	McCown	1, 30	
	A6	US- 4,129,617	12-12-1978	Machi et al.	000	
	A7	US- 4,171,397	10-16-1979	Morrow		
	A8	US- 4,321,404	03-23-1982	Williams et al.		
	A9	US- 4,358,559	11-09-1982	Holcomb et al.		
	A10	US- 4,404,247	09-13-1983	Dominguez-Burguette et al.		
	A11	US- 4,508,916	04-02-1985	Newell et al.		
	A12	US- 4,543,268	09-24-1985	Sidney et al.		
	A13	US- 4,559,382	12-17-1985	Martens et al.		
	A14	US- 4,567,073	01-28-1986	Larson et al.		
	A15	US- 4,594,262	06-10-1986	Kreil et al.		
	A16	US- 4,731,273	03-15-1988	Bonk et al.		
	A17	US- 4,830,910	05-16-1989	Larson		
	A18	US- 4,933,060	06-12-1990	Prohaska et al.		
	A19	US- 4,985,473	01-15-1991	Williams et al.		
	A20	US- 5,037,668	08-06-1991	Nagy		
	A21	US- 5,112,882	05-12-1992	Babu et al.		
	A22	US- 5,209,984	05-11-1993	Rolando et al.		
	A23	US- 5,276,079	01-04-1994	Duan et al.		
	A24	US- 5,283,101	02-01-1994	Li		
	A25	US- 5,389,376	02-14-1995	Duan et al.		
	A26	US- 5,492,599	02-20-1996	Olson et al.		
	A27	US- 5,512,225	04-30-1996	Fukushi		
	A28	US- 5,618,899	04-08-1997	Appelt et al.		

*Examin	er:
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Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Page 2 of 2

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First Named Inventor	Yamanaka, Keizo
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Attorney Case Number	54888US006

U.S. Patent Documents					
Exam.	Cite	Document Number	Publication Date or	Name of Patentee	Pages, Columns, Lines, Where
Init.*	No.		Issue Date MM-DD-YYYY	or Applicant of Cited Document	Relevant Passages or Relevant Figures Appear
	A29	US- 5,668,210	09-16-1997	Harris et al.	
	A30	US- 5,686,544	11-11-1997	Pocius	2
	A31	US- 5,738,746	04-14-1998	Billingsley et al.	YAN CRI

<u></u>			F	oreign Patent	Documents	6 %	The last
Exam.	Cite	For	eign Patent Document	Publication Date	Name of Patentee or	Pages, Columns Lines,	ranslation
Init.*	No.	Ctry. Code	Number-KindCode (If known)	MM-DD-YYYY	Applicant of Cited Document	Where Relevant Passages or Relevant Figures Applea	(Check if yes)
₩ ₩	B1	JP	JP03250034 A	11-07-1991			
			(English Abstract)				
×	B2	JP	4-232738	08-21-1992			
			(English Abstract)				
1/	В3	JP	9-156036 A	06-17-1997			
			(English Abstract)				į
~	B4	wo	WO 95/26281 A2	10-05-1995			
	B5	wo	WO 95/33013	12-07-1995			_
V	B6	wo	WO 97/00297	01-03-1997			
V	B7	wo	WO 98/08879	03-05-1998			

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS				
Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published		
V	C1	Article: El-Assy et al., "Radiation Initiated Grafting Onto Fluoro Polymers for Membrane Preparation," Radiat. Phys. Chem., Vol. 30, No. 4, (1987), pp. 237-242.		
V	C2	Article: Dworjanyn et al., "The Role of Multifunctional Acrylates in Radiation Grafting and Curing Reactions," Radiat. Phys. Chem., Vol. 33, No. 5, (1989), pp. 429-436.		
$\lfloor floor$	C3 Article: Kabanov et al., "Present Status and Development Trends of Radiation-Induced Graft Polymerization," <u>Radiat. Phys. Chem.</u> , Vol. 37, No. 2, (1991), pp. 175-192.			

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